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The evolution of InAs quantum dots grown on InP substrates by metal-organic vapour phase epitaxy is studied as a function of InAs coverage. Under specic growth conditions, the onset of the two-to three-dimensional transition is seen to proceed via two distinct pathways: through (i) an abrupt appearance of quantum dots as expected in the usual Stranski-K rastanov growth picture and (ii) a continuous evolution of small surface features into well developed quantum dots. The average size of the features in both these families increases with coverage, leading to a bim odal distribution in dot sizes at an intermediate stage of growth evolution that eventually becomes a unimodal distribution as more material is deposited. Complementary information obtained from independent measurements of photolum inescence spectra and surface morphology is correlated and is found to be independently consistent with the picture of growth proposed.

PACS num bers: 68.65 Hb, 78.67 Hc, 81.07 Ta, 68.37 Ps, 81.15 Gh

The semiconductor heterostructures grown via the strain-mediated Stranski-Krastanov (S-K) route[1, 2] have been of special interest. The resulting self assem bled clusters are extremely small (10nm, hence called quantum dots), coherently strained (hence optically active) and have a size dispersion that may be acceptable for their use in real optoelectronic devices, e.g., [3, 4]. The S-K transition has been systematically studied in m ost III-V sem iconductors of interest (e.g. InAs/GaAs [5, 6, 7, 8, 9],  $In_{1 \times} Ga_{x}As/GaAs[10, 11]$ , InAs/InP[12], GaSb/GaAs[13]). While the growth route may be rationalized by energetic considerations that predict an initial two-dimensional growth followed by an abrupt appearance of three-dim ensional clusters upon the wetting layer'[1], the actual process of self-assembly is complicated by kinetic e ects, substrate conditions and orientation, a non-quiescent wetting layer during growth evolution, alloying and long-ranged substrate-mediated elastic interactions. For example, it has also been observed, though not consistently by di erent groups, that there may be redistribution of matter leading to a decrease in the quantum dot (QD) size with coverage. Often a bim odal size distribution [5, 12] has also been observed at an interm ediate growth stage. A lthough many of these phenom ena have been described in term sofelastic energy barriers corresponding to change in shape and a maximum permissible size for quantum dots beyond which they are dislocated, the complex growth evolution of self-assembled dots, especially under far from equilibrium (usual) growth conditions, is still very much an open problem despite more than a decade of extensive work.

In this paper, we focus on InAs/InP self-assembled QDs grown by metal-organic vapour phase epitaxy (MOVPE)[14, 15]. The samples are studied at dierent stages of evolution by independently studying and quantitatively correlating them orphology and the optical emission spectra. Contrary to many of previous reports, we have, on samples grown under more non-equilibrium conditions (lower temperature, 450 C and higher growth

rate  $1-2\,\mathrm{m}$  onolayers (M L) per second) where surface kinetics m ay be an important limiting step, observed that the 2D-3D transition is not completely abrupt and proceeds via two dierent pathways. This study also yields a dierent picture for bim odality in the QD's size distribution.

Growth was carried out using low pressure (100 torr) MOVPE on n+ doped (001) \epi-ready" InP substrates in a horizontal reactor with hydrogen as the carrier gas. Group III and V sources were trim ethyl-indium and arsine and phosphine respectively. Prior to InAs growth, a InP bu er layer was grown rst at 625C and then with the temperature continuously ramped down and stabilized to 450 C. In As layers were grown at a relatively low temperature of 450 C at a growth rate [16] of approxim ately 1.8M L/s. A pair of sam ples was grown with identically deposited InAs layer in two growth runs. In the rst case, the sample was taken out of the reactor after InAs deposition itself to enable a study of surface m orphology and in the second case a InP cap layer was grown for sam ples used for photolum in escence study. For these samples, about 50 A InP was deposited at the In As deposition temperature to avoid any further ripening during the higher temperature overgrowth. Surface features were studied ex-situ using an atom ic force microscope (AFM) in contact mode, typically within a few hours of sam ple growth. The PL spectra were measured at 25 K at low enough excitation power ( $0.5W = cm^2$ ) to preclude any subband lling and were corrected for the system response using a standard black body source.

Fig. 1 (inset) shows 1 m 1 m AFM scans for samples with progressively increasing InAs coverage in Fig. 1(a) to (d). The histograms of the island heights corresponding to these AFM in ages are shown in the main Fig.1. All well-separated (  $20 \, \mathrm{nm}$ ) convex features with heights above two ML were counted here. Fig.1 (a) depicts an early stage of growth. Here we observe that along with very few (  $5 \,$   $10^8 \,$  cm  $^2$ ) well developed

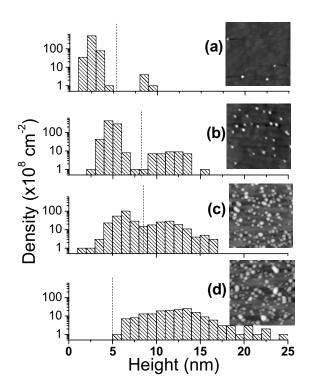


FIG. 1: H istogram of island heights inferred from 1 m 1 m AFM im ages on samples with increasing InAs coverage. The coverage is approximately: (a)  $4.5 \mathrm{M}$  L, (b)  $6.5 \mathrm{M}$  L (c)  $9 \mathrm{M}$  L (d)  $14.5 \mathrm{M}$  L. The coverage is calibrated against the W L P L peak in Fig.2 (a). See text. The dotted line depicts the separation of the islands into two families, evidently evolved from two di erent routes (see Fig.3). This leads to a bim odal size distribution (a)—(c) which m erges into a single broad distribution (d).

(height > 8 nm) QDs, there are many small surface features of minimum height of 14A and a mean height of 26A contributing to a large number of counts at low heights. Furtherm ore, in Fig. 1 (b)-(c), we observe that these small surface features are stable and continuously grow in size as more material is deposited. Therefore, with incremental coverage, Fig.1 (b)-(d), the morphology evolves as (i) matter is accreted by all pre-existing features making them grow in size (ii) new well developed QDs of height 8nm are spontaneously generated (usual S-K transition). Growth via two independent pathways naturally leads to a bim odal size distribution at an intermediate stage of growth, Fig.1 (c). The role of existing (two-and quasi-three-dim ensional) surface features during the S-K transition has been much discussed [6, 7, 17]. Here these surface corrugations are only being connected to dots which continuously evolve in size and we have not exam ined their role, if any, as precursors to abruptly generated well developed dots (S-K transition).

The above mentioned picture of growth evolution is independently observed in optical properties. Fig.  $2 \, \text{shows}$ 

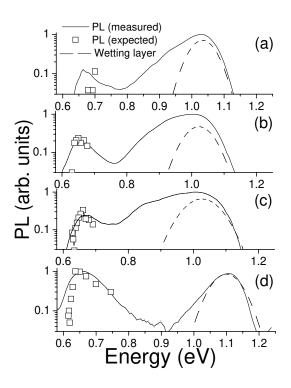


FIG. 2: (Solid line) 25K PL Spectra. The growth conditions for sam ples whose response is depicted in (a)-(d) are the sam e as their counterparts in Fig. 1, except for the InP overgrowth, (Squares) Calculated transition energies [26] scaled with the heights histogram (Fig. 1) in an attempt to reconstruct the PL spectra. The expected response from only the features higher than the cut-o depicted by dotted lines in Fig. 1 is shown. Note that there is no thing parameter. The higher energy feature is the to two Gaussians. (Dotted line) Wetting layer contribution to PL.PL from the wetting layer appears at 1.02 1.03 eV in (a)-(c) and shifts to 1.10 eV for (d). See text. The other the corresponding to the evolution of small surface features is not shown here for brevity.

the low temperature PL spectra measured on the four similarly grown but capped samples. A long with the characteristic PL from well-developed dots, the PL spectrum also shows a wetting layer peak around  $1.02\,\,1.03\,$  eV that is broadened towards lower energy by the emission from these optically active quasi-three-dimensional clusters. The spectrum in Fig 2 (c) shows almost three distinct peaks corresponding to the wetting layer and the two kinds of quantum dots. Finally, in the saturation regime (when the number of well resolved QDs does not increase with coverage), the distribution of the dot sizes is again roughly unimodal, but with a large dispersion.

The optical signature from the wetting layer was inferred by thing two Gaussians, (corresponding to signals from WL and quasi-three dimensional clusters) to the high energy PL peak. We observe that the wetting layer peak is constant to within 10m eV in Fig2(a)-(c). This low temperature PL peak at around 1.02 1.03 eV corre-

sponds to an approximately 4.5 ML strained InAs/InP quantum well[18]. This value may be used to calibrate the thickness with the deposition time, which is otherwise di cult to estimate with sub-M L precision in a typical MOVPE set-up without in-situ diagnostic tools. It is worth pointing out that there has been a wide variation in the reported value of the wetting layer thickness for InAs/InP, with the lower limit being [19, 20]. With a lower growth temperature, the wetting layer thickness is expected to be (exponentially) larger than its equilibrium value [21], since the former is inversely dependent on the di usion length [22]. Because 450 C is among the lower reported growth temperatures for InAs dots, a thicker wetting layer is naturally expected. Remarkably, a recent reection high energy electron di raction study [23] on 2D-3D transition in MBE grown InAs/InP lm s, reports for growth at 450 C, a value of the wetting layer thickness that is very sim ilar to what we have inferred from the PL spectra.

Finally, in Fig. 2(d), the wetting layer PL shifts to a higher energy, 1.10 eV indicating the well known narrowing of wetting layer in the saturation regime [24].

The observed PL spectra from QDs should in principle be derivable from the quantitative analysis of the AFM images [25]. Using published ground state energy calculations [26] for InAs/InPQDs, the expected emission spectra from large dots are shown in Fig 2 (open squares). While there is a good quantitative agreement without any

tting param eter for the expected and observed spectral features from large dots (those above the size cut-o depicted by dotted lines in Fig. 1), the PL from the smaller features in each histogram did not agree as well and is therefore not shown in Fig 2. It has been previously established that the capping process can considerably change the morphology of the individual quantum dots and it is likely that the smaller dots are more affected by capping [27, 28] and compositional changes due to the As/P exchange during the early stage of InP overgrow th.

Implications: We have observed that the 2D-3D transition is not abrupt and the bim odality in the QD's size distribution at an intermediate stage of grow th is a consequence of the grow the evolving via two distinct pathways. These two observations are contrary to previous studies on InAs/GaAs[5, 6] and In<sub>x</sub>Ga<sub>1 x</sub>As/GaAs[10] where the 2D-3D transition had been found to be abrupt and thermodynamically rst-order with the surface coverage playing the role of a critical parameter [5]. An abrupt appearance of quantum dots beyond a critical coverage has also been theoretically reproduced within a rate equation based model [29].

B in odality in dot sizes also implies that the QDs ensemble cannot be characterized by a single length scale (e.g., mean island size) [2] during most of the evolution and rules out the very attractive possibility of data collapse onto a universal scaling [30] function during intermediate stages of growth. Absence of scaling at an intermediate growth stage has actually been observed by

Krzyzewski, et al. (e.g., see ref. [1]). The issue of bim odality in dot sizes at intermediate coverage, although not fully resolved, is typically explained by the presence of energy barriers [31] corresponding to another (shapedhange, from pyramid to dome) rst order transition that has been experimentally studied in SiGe/Si [32], GaN/AIN [33] and InAs/GaAs [34].

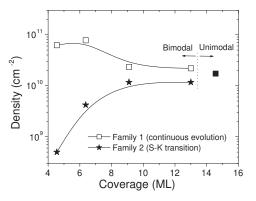


FIG. 3: Variation of the island density with coverage for the two families of islands corresponding to the two modes in the heights distribution in Fig. 1. Solid square represents the late stage when the distribution is um im odal (Fig. 1 (d)).

It is instructive to (visually) separate [8] the heights histogram s in Fig. 1 at the minima between the two modes (dotted lines in Fig.1). Fig.3 is the corresponding plot of cluster densities in these two families (S-K dots and continuously evolving clusters) as a function of coverage. The increase in the density of larger dots with coverage is abrupt, whereas the number of smaller features decreases with coverage due to coalescence. At large enough coverage the distribution become sun in odal. Without invoking the existence of energy barriers, this is most simply understood as being due to the dierence in growth rates of larger and smaller dots (due to their dierent volumes).

Am ong the various studies of growth evolution, the results in references [8, 9], although on MBE grown In A s/G a A s, are qualitatively most similar to ours. Nevertheless there are some important di erences both in data and interpretation of results. Firstly, the quasithree dim ensional clusters were thought to be precursors to all the quantum dots giving a common origin to the dots in both the fam ilies. Possibly due to a smaller strain in the InAs/InP system as compared to InAs/GaAs, we observe an uninhibited increase in size and a corresponding redshift in PL with coverage. This is in contrast with InAs/GaAsQDs, where a pronounced barrier seems to restrict the maximum dot size to 8nm. This supports the general observation of larger dispersion in dot sizes and low temperature PL linewidths (100m eV) in InAs/InP.

The di erences observed in growth evolution by di erent groups may be a result of di ering substrate/bu er layer conditions. It is possible for the local roughness in the wetting layer surface to stabilize pre-existing quasithree dimensional surface structures and determ ine the extent of bim odality at an intermediate growth stage. Many of the thermodynamic arguments used to describe the QD self-assembly are relevant only under quasiequilibrium conditions of growth which many such previous experiments tried to maintain. Our results, on the other hand, are obtained under much higher growth rates, more typical growth conditions of quantum dots. Conclusions: Studying the growth evolution of MOVPE

grown InAs/InP self-assembled quantum dots, we have observed that an alternate pathway for the 2D-3D transition exists that naturally explains the offen observed bim odality in the quantum dots size distribution at an intermediate growth stage. Independent evaluations of the morphology and the photolum inesence spectra are consistent with the picture of growth presented.

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